



## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hidekazu MORIYAMA

Group Art Unit: 1762

Application No.: 10/827,317

Examiner:

J. LIN

Filed: April 20, 2004

Docket No.:

119294

For:

PATTERN FORMATION METHOD, DEVICE MANUFACTURING METHOD,

ELECTRO-OPTICAL DEVICE, AND ELECTRONIC APPARATUS

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the September 13, 2007 Office Action, please consider the following:

Amendments to the claims as reflected in the listing of claims; and

Remarks.